



**REPLY UNDER 37 CFR 1.116  
EXPEDITED PROCEDURE  
TECHNOLOGY CENTER 2800**

Attorney Docket No. 051876P352

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Patent Application of:

**Byung-Seop Hong**

Serial No. 10/648,183

Filed: August 25, 2003

For: **METHOD FOR RELEASING STRESS  
DURING SEMICONDUCTOR DEVICE  
FABRICATION**

Examiner: Trung Q. Dang

Art Unit: 2823

*Interrel  
PCE  
6-2005  
Amish  
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Mail Stop A/F  
Commissioner for Patents  
Post Office Box 1450  
Alexandria, Virginia 22313-1450

**AMENDMENT AND RESPONSE TO FINAL OFFICE ACTION**

Sir:

In response to the Final Office Action mailed February 24, 2005, regarding the above-referenced application, Applicant respectfully requests entry of the amendment set forth below in consideration of the remarks that follow.